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**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**

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**C mplete if Known**

Application Number	10/037,146
Filing Date	12/21/2001
First Named Inventor	Painter
Art Unit	2874
Examiner Name	Eric K Wong
Attorney Docket Number	CQC13NP

Sheet 1 of 6

**U. S. PATENT DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code <sup>2</sup> (if known)			
		US- 6,580,851-B1	06-17-2003	Vahala et al	
		US- 6,633,696-B1	10-14-2003	Vahala et al	
		US- 2001-0004411-A1	06-21-2001	Yariv	
		US- 2001-0033587-A1	10-25-2001	Painter et al	
		US- 09/788,303	filed 02-16-2001	Sercel et al	
		US- 2002-0041730A1	04-11-2002	Sercel et al	
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		US- 4,515,431	05-07-1985	Shaw et al	
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		US- 5,471,551	11-28-1995	Kragl et al	

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		FR 2,739,195	03-28-1997	Knight et al		

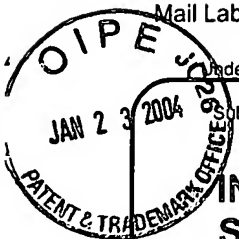
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		US- 5,479,548	12-26-1995	Cote et al	
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Sheet **3** of **6**

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Attorney Docket Number	CQC13NP

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**NON PATENT LITERATURE DOCUMENTS**

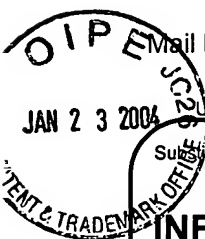
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
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Examiner Signature	Date Considered
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Sheet	5	of	6
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